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14. ABSTRACT Three auto-collimating flats (ACFs) of 1.5 meter clear aperture are being manufactured for use in the JSC Cryo-Optical Metrology test of the James Webb Space Telescope. In-process interferometric testing of the ACFs is used to guide their surface-figure processing. The surface measurement is performed in a vacuum chamber at both room (+20 °C) and cryogenic (-240 °C) temperatures. With a 12-inch beam diameter FizCam interferometer, sub-aperture measurements are taken across the ACF diameter at multiple rotations. These measurements are stitched together to compute the surface figure. The figure change between room-temperature and cryogenic temperature is measured and used to enable cryo-figuring based on room-temperature measurements. The data analysis is calibrated to account for gravity sag on test-set optics and surface aberrations caused by vacuum pressure and temperature gradients on vacuum-chamber windows. The completed ACFs will have a surface error of less than 75 nm RMS.					
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In-Process Testing For Cryo-Figuring 1.5 meter Diameter Auto-Collimating Flats

June 7, 2010

presented by

**David J. Fischer, Ph.D.
ITT Geospatial Systems**



3 Autocollimating Flats used in Cryo-Optical Test of JWST

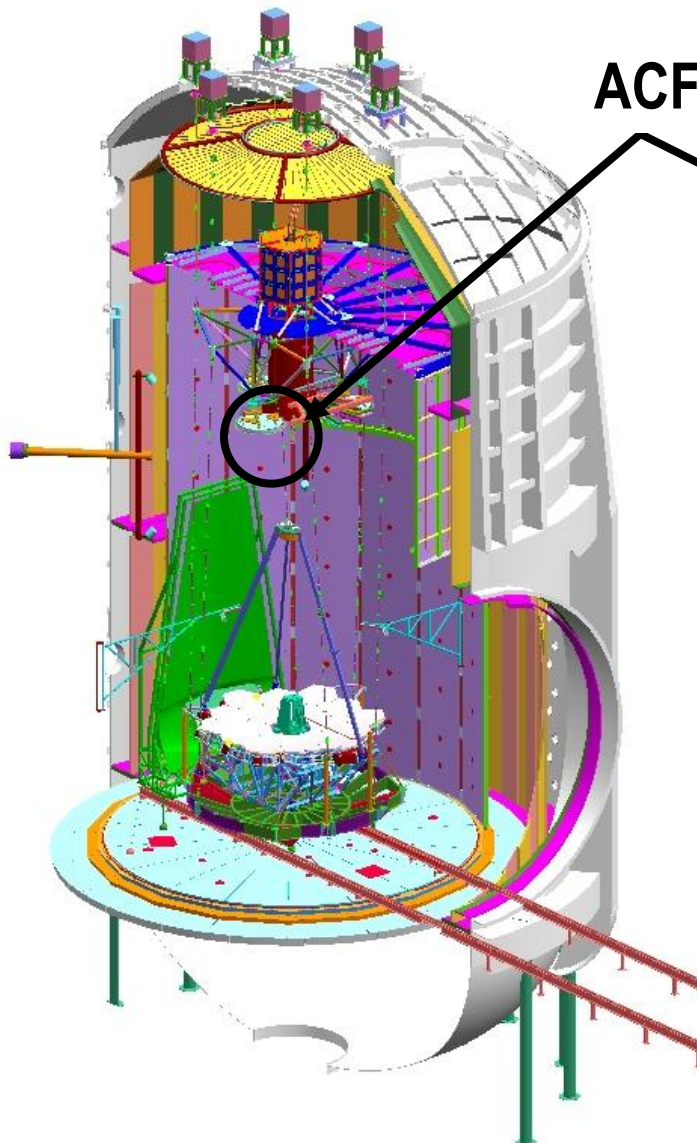


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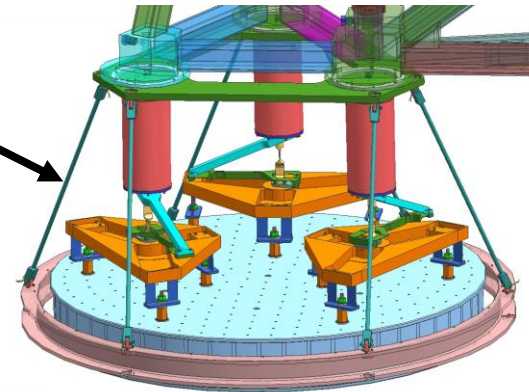
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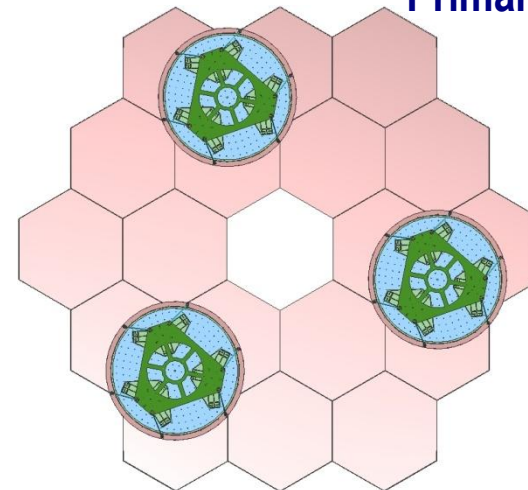
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ACF



ACF Footprint on
Primary Mirror





Skip Test Used for Cryo-Figuring ACFs

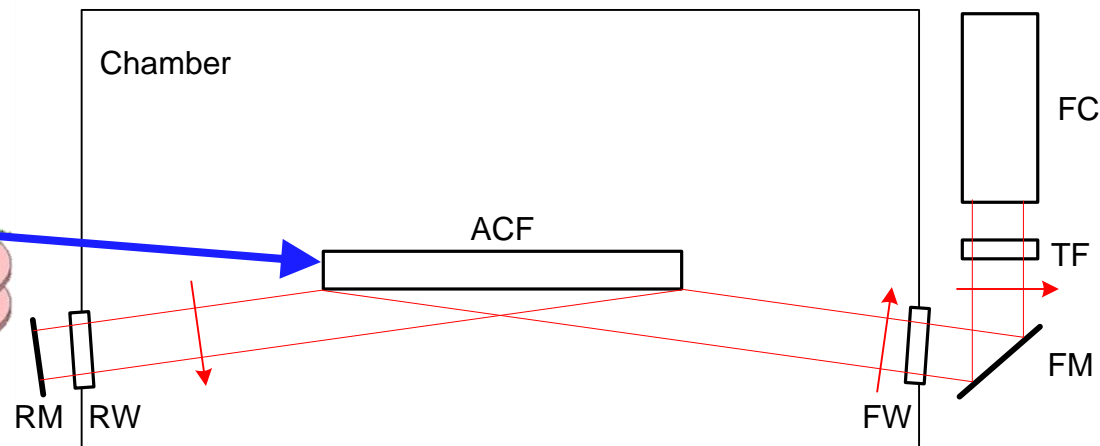
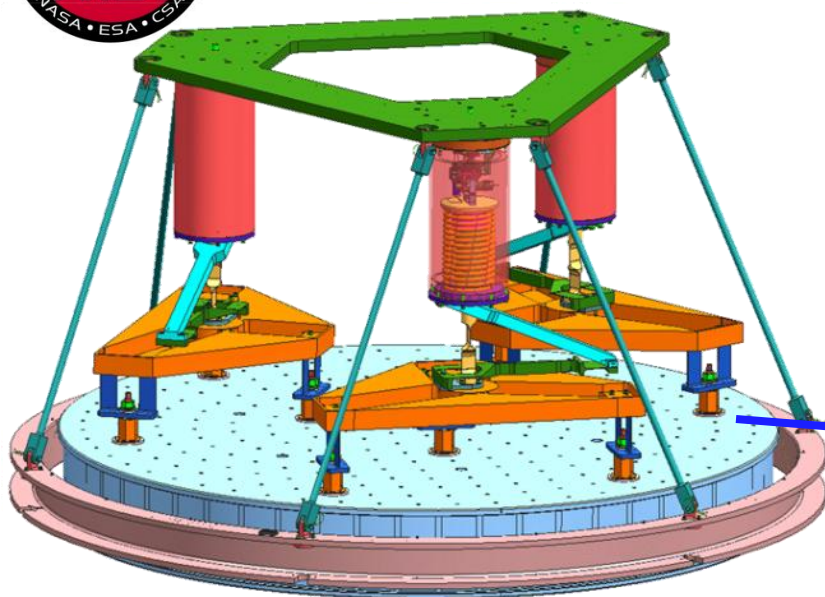


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■ Cryo-Vac Skip Test for 32.8 K ACF

- 300 mm beam ($\lambda=660$ nm) “skips” across ACF diameter at 8.213°
- 60 sub-aperture Slices at 6° rotations measure entire surface
- Cryo Backout computed, applied to slice
- Slices stitched together compute surface map

■ Requirements

- Clear Aperture of 1.520 m
- 75 nm surface rms (including test uncertainty)
- Uncertainty requirements on power and astigmatism



CAD Model of Skip Test



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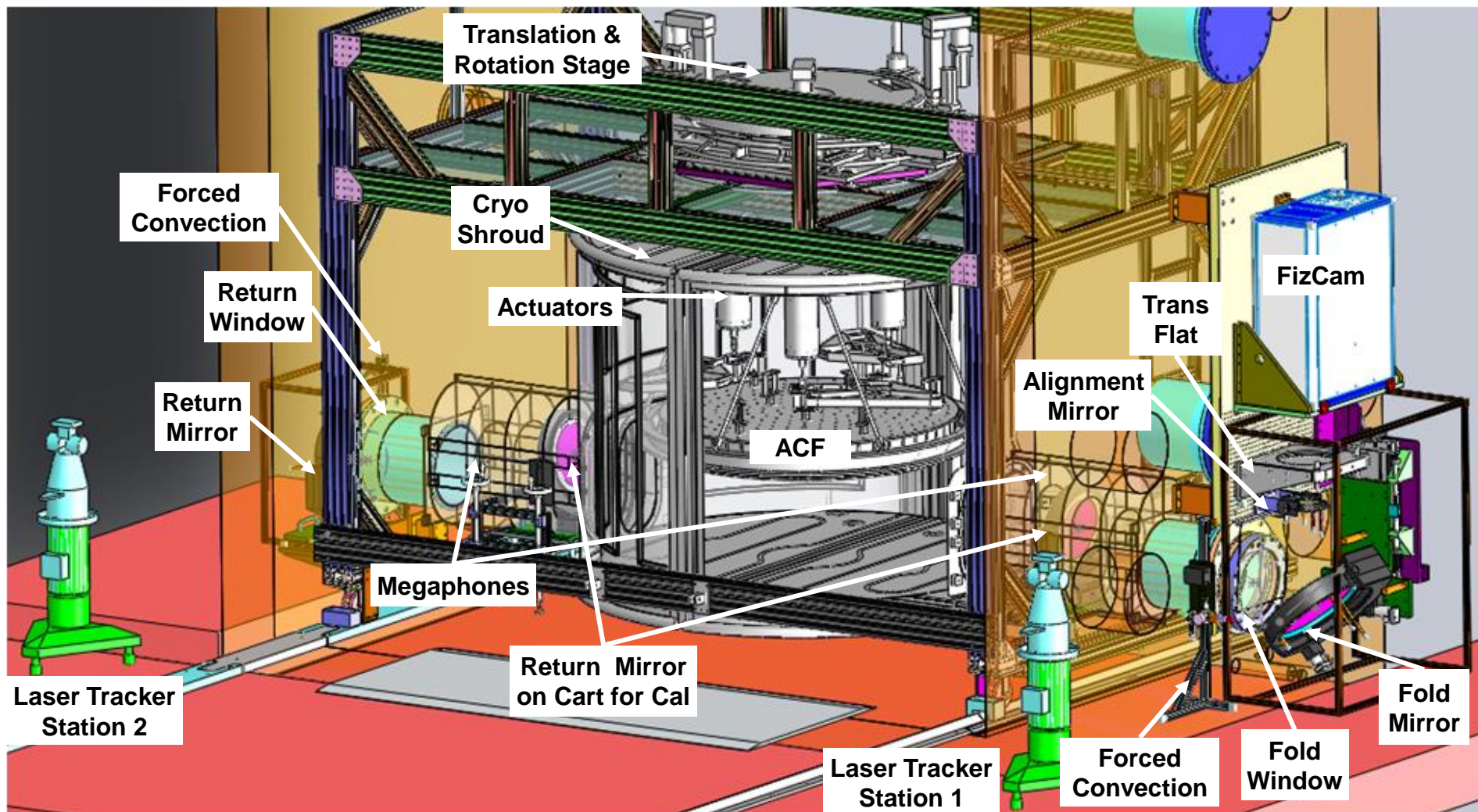
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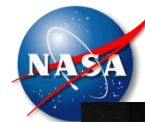


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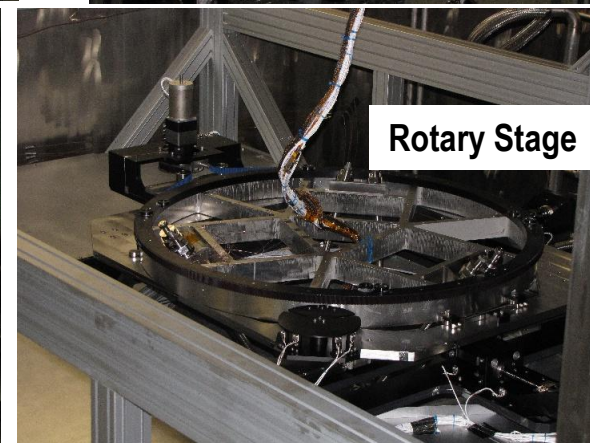
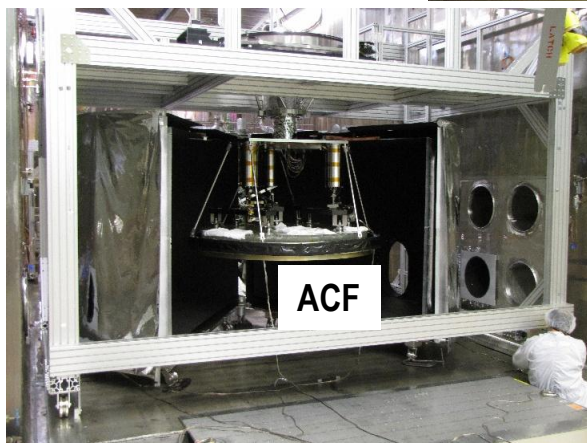
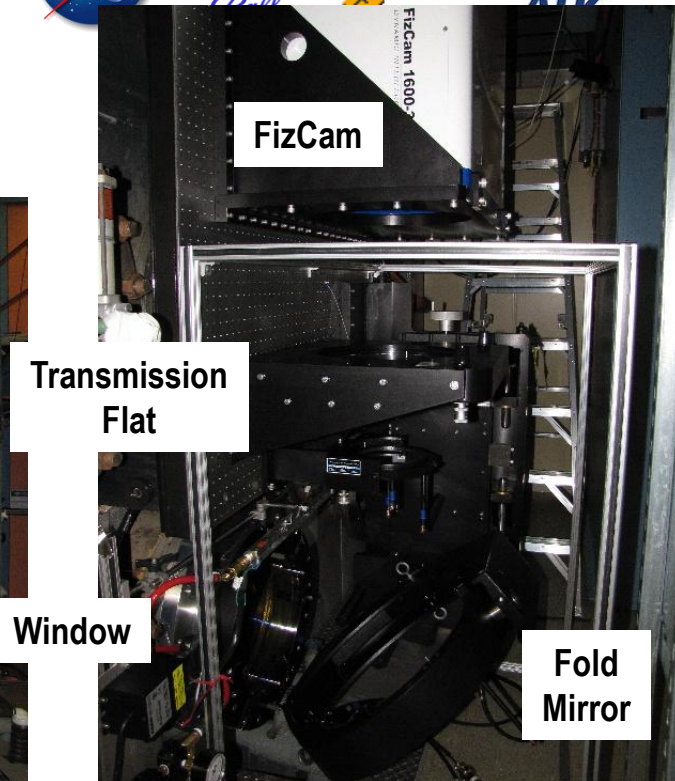
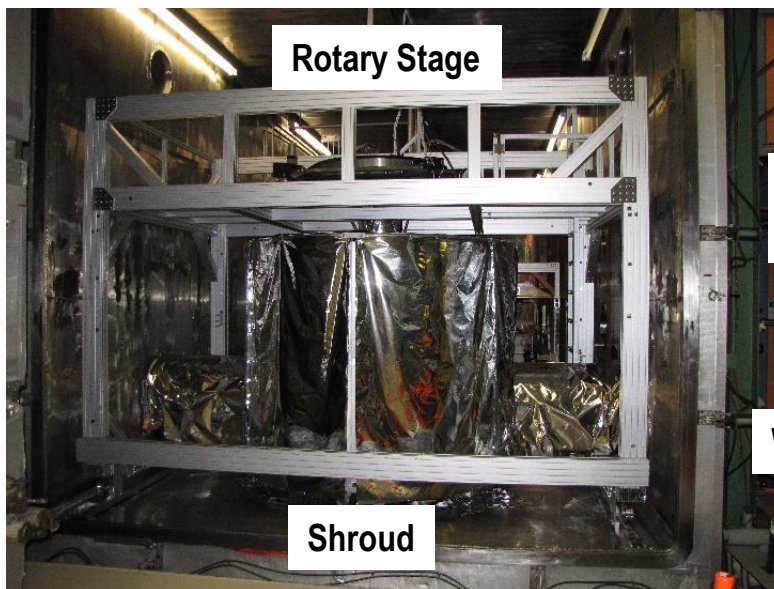
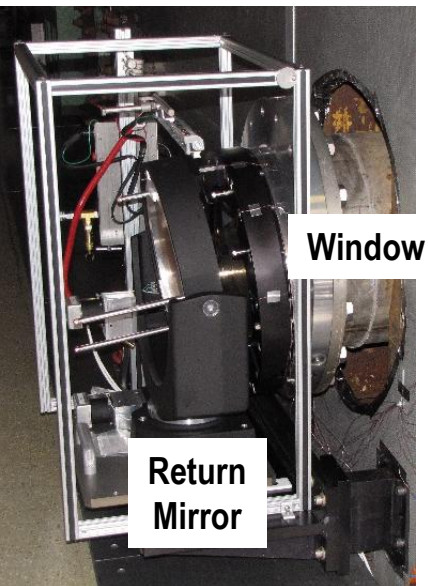
Photographs of Skip Test Hardware



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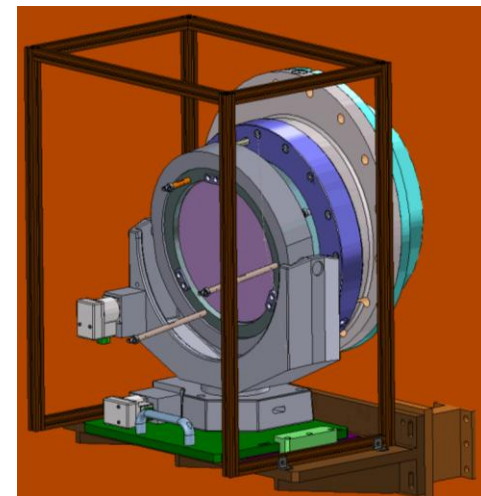
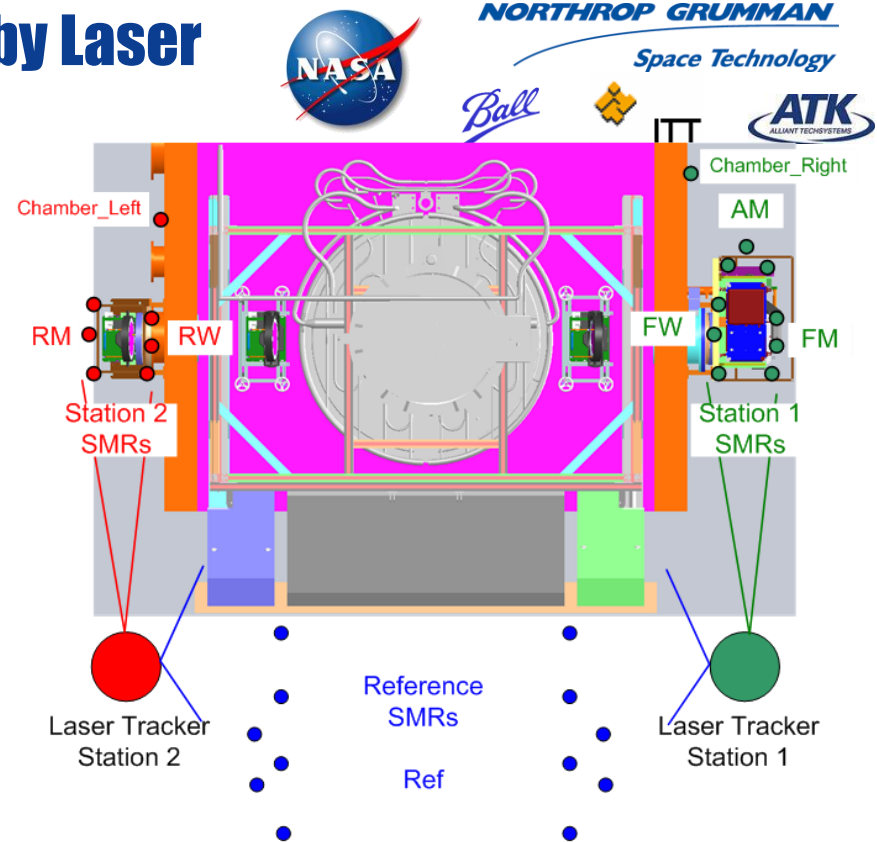
ATK





Initial Alignment of Test Set by Laser Tracker

- Align FizCam Transmission Flat and Alignment Mirror (AM)
- Initial alignment by Laser Tracker
 - Align Return Mirror (RM)
 - Coarse align Fold Mirror (FM)
- RM aligned 1 arcmin (0.017°) accuracy per Theodolite
- Laser Tracker shows ACF bias of 12 arcmin (0.2°)





Optical Alignment by FizCam



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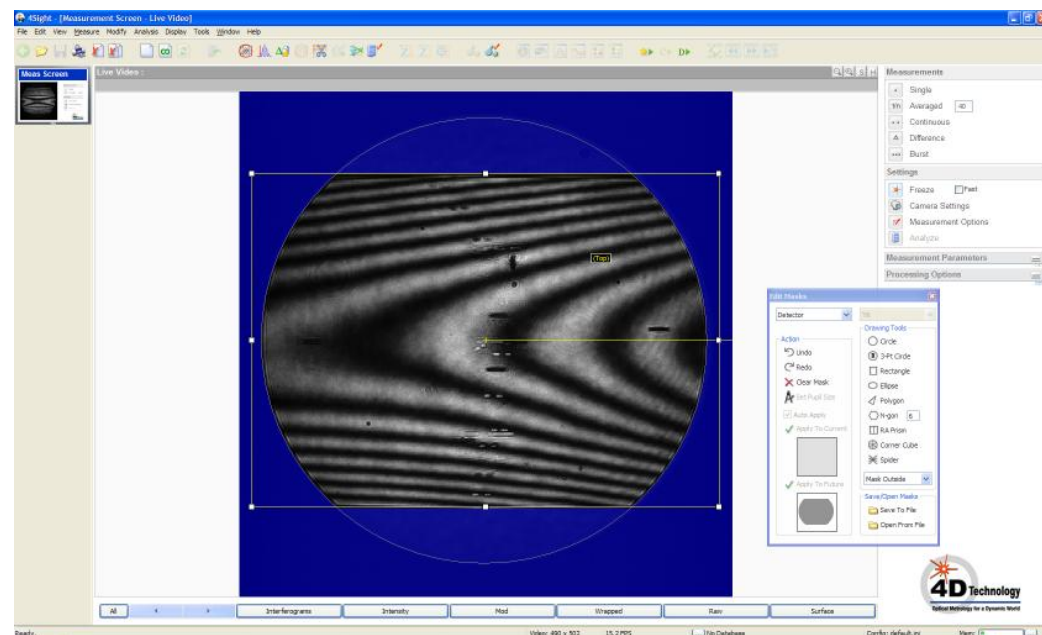
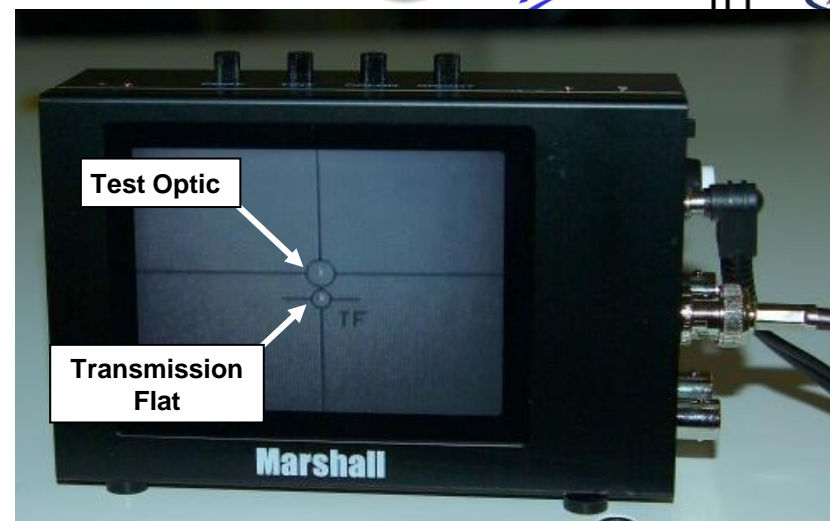
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- Align FizCam's Transmission Flat
- Align Return Mirror by Laser Tracker
- Align FM by Alignment Monitor
- Null fringes with FM
- Adjust ACF centration by live video





Description of Stitching Approach



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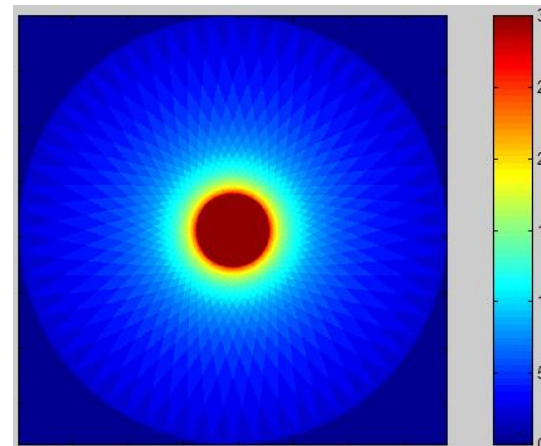
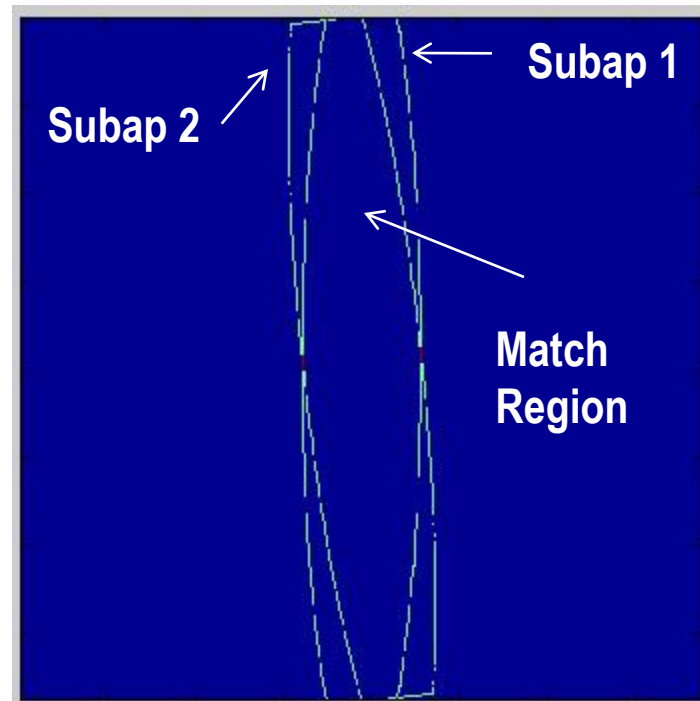


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1. Interferograms Scaled, Stretched and Rotated by Nominal Geometry
2. 1st Subap is Reference for Scale
3. Nth Subap Matched to N-1th Subap in data overlap region & replaced with Match. Matching done by fitting tilt & scale
4. Final Map is Sum of Adjusted Subaps, normalized Pixel-by-Pixel using Sub-Ap Pixel Map

Variations on : Otsubo M. et al, "Measurement of large plane surface ...", Opt. Engineering 33, 608-613 (1994).



Sub-Ap
Pixel Map



ACF Surface Computed by Stitching 60 Slices (6° Rotations)

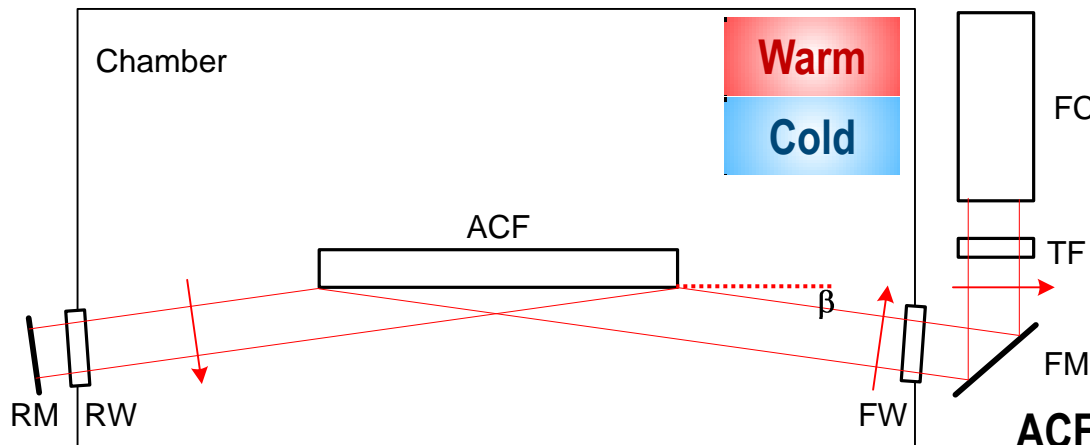


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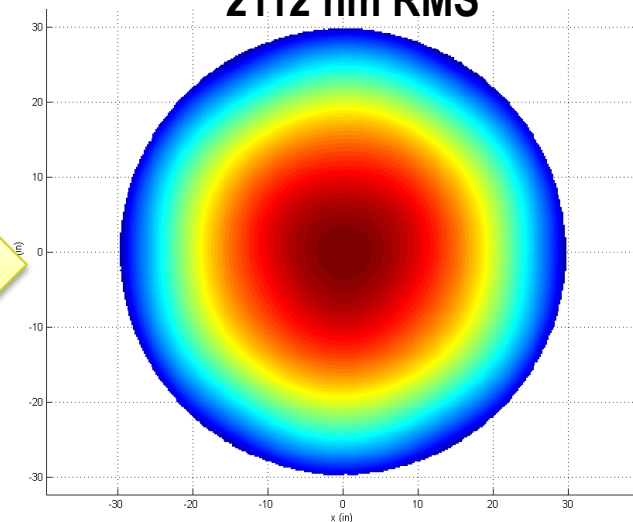
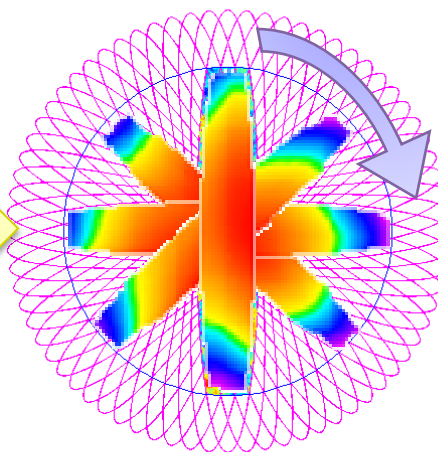
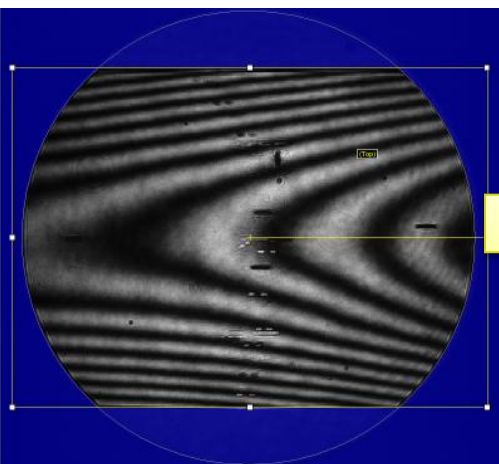
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**ACF Surface at 32.8 K
2112 nm RMS**



$$W_{M,n} = 2FC + 2TF + 4FM + 2FW + 2RW + 2RM + 4 \sin \beta \Delta ACF_n$$

22 CFR 125.4(b)(13) Applicable



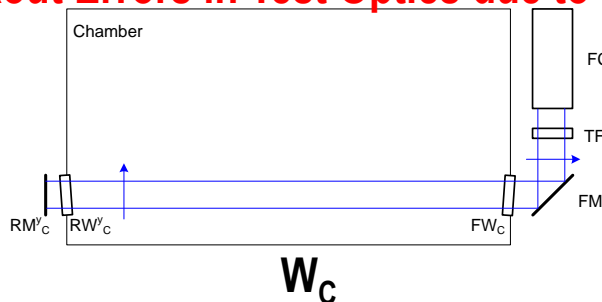
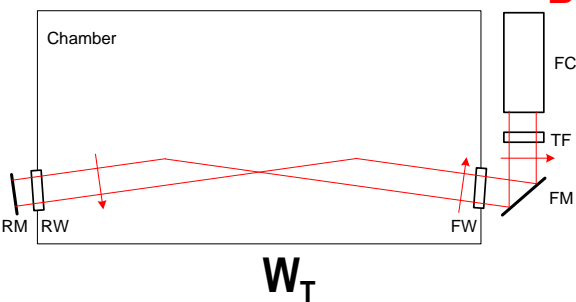
Cryo Backout: Test Set + Cryo-Delta



$$W_B = W_T|_{WARM} \leftarrow \text{Backout Errors in Test Optics at Warm-Vac}$$

$$+ \frac{1}{2} \left[W_C + W_C^y \right] + \left[W_M - W_M^y \right]_{CRYO} - \frac{1}{2} \left[W_C + W_C^y \right] + \left[W_M - W_M^y \right]_{WARM}$$

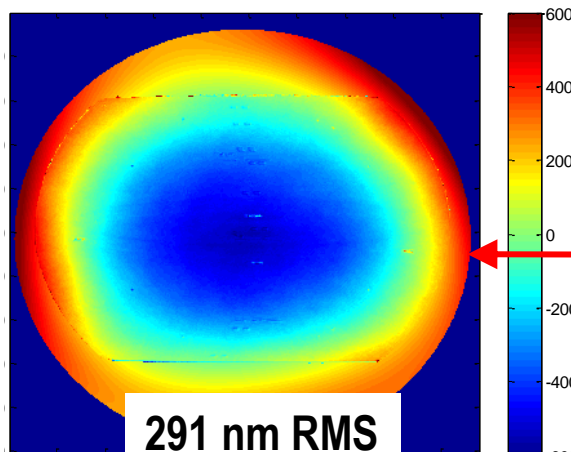
Backout Errors in Test Optics due to Cryo Shift



$$\frac{1}{60} (\text{Slice 1} + \text{Slice 2} + \text{Slice 3} + \dots + \text{Slice 60})$$

W_M

$$W_B =$$



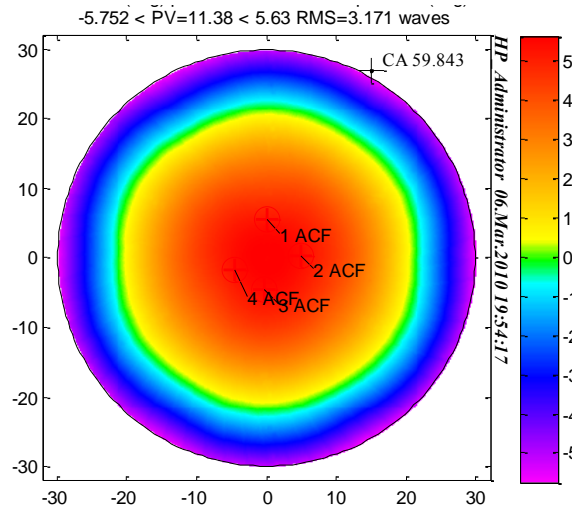
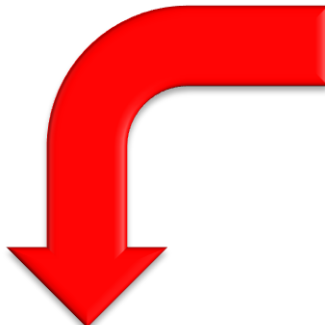
Subtract Extrapolated Backout from each Slice before Stitching



Backout Improves Stitching Results

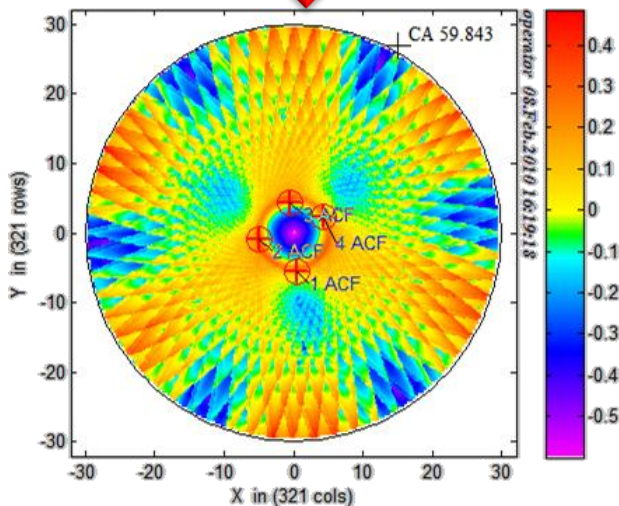
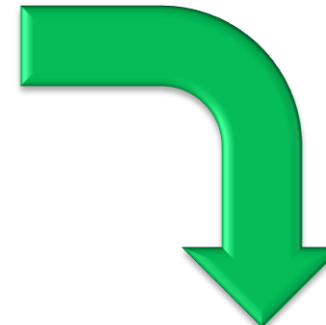


No Backout
Clear Stitching Artifacts
Higher Surface Residual

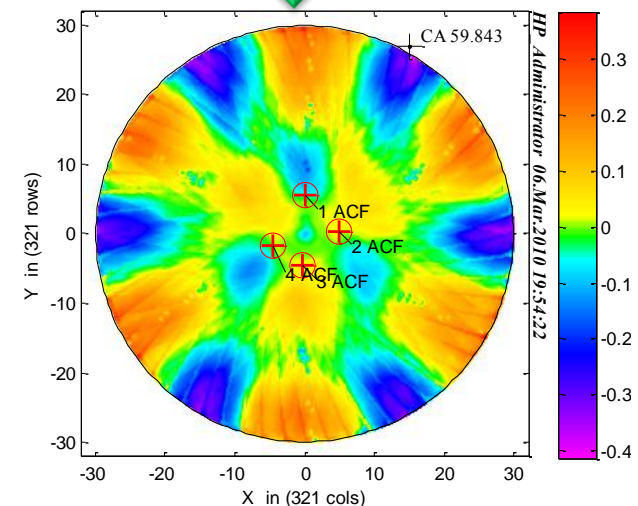


ACF Surface at 32.8 K
2112 nm RMS

Use Cryo Backout
Smoother Surface
Smaller Surface Residual



37-Zernike Fit Residual
95 nm RMS



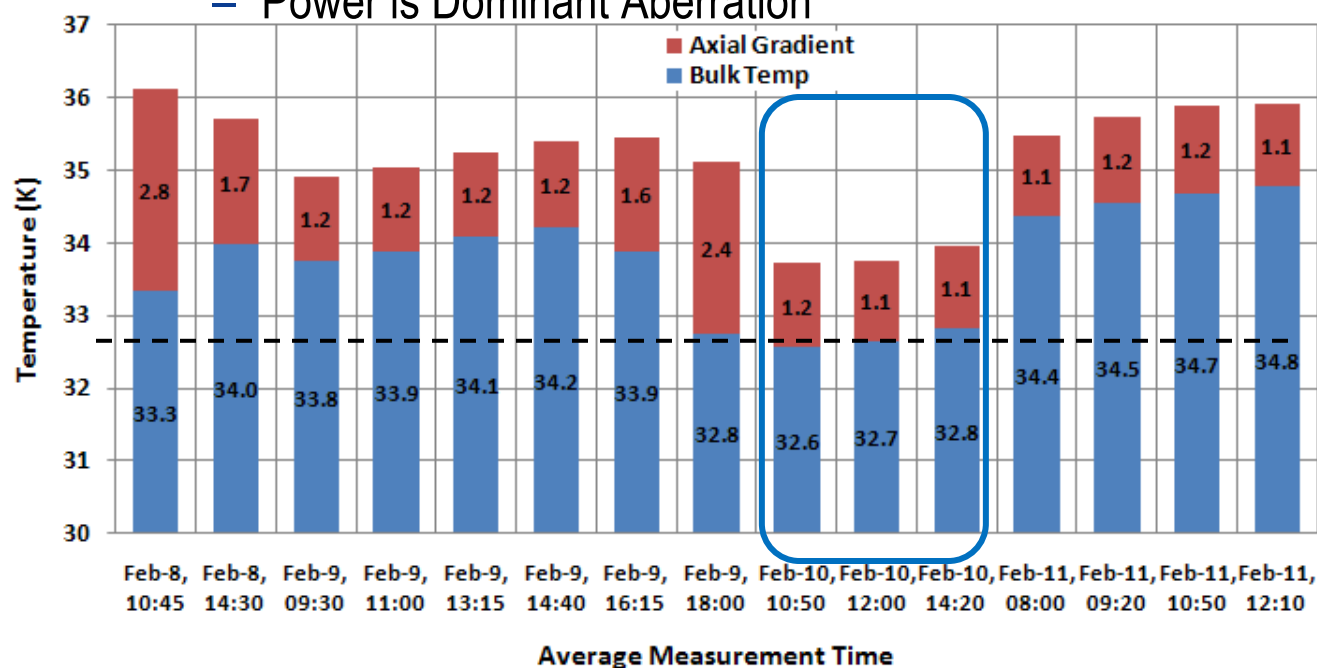
37-Zernike Fit Residual
77 nm RMS



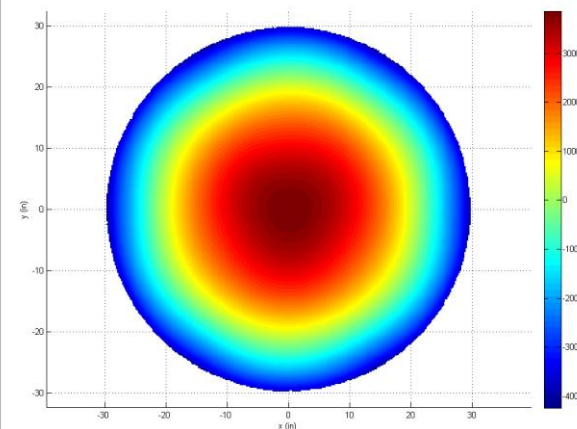
Cryo Testing Successful



- Pre-Ion 1 Skip Test Complete
- Warm Vac
 - Figure agrees with OAGM Probe
- Cryo-Vac (32.8 K)
 - Hitmap: 3 Surface Maps from Feb 10
 - Close to Warm Vac
 - Power is Dominant Aberration



ACF Surface at 32.8 K
2112 nm RMS



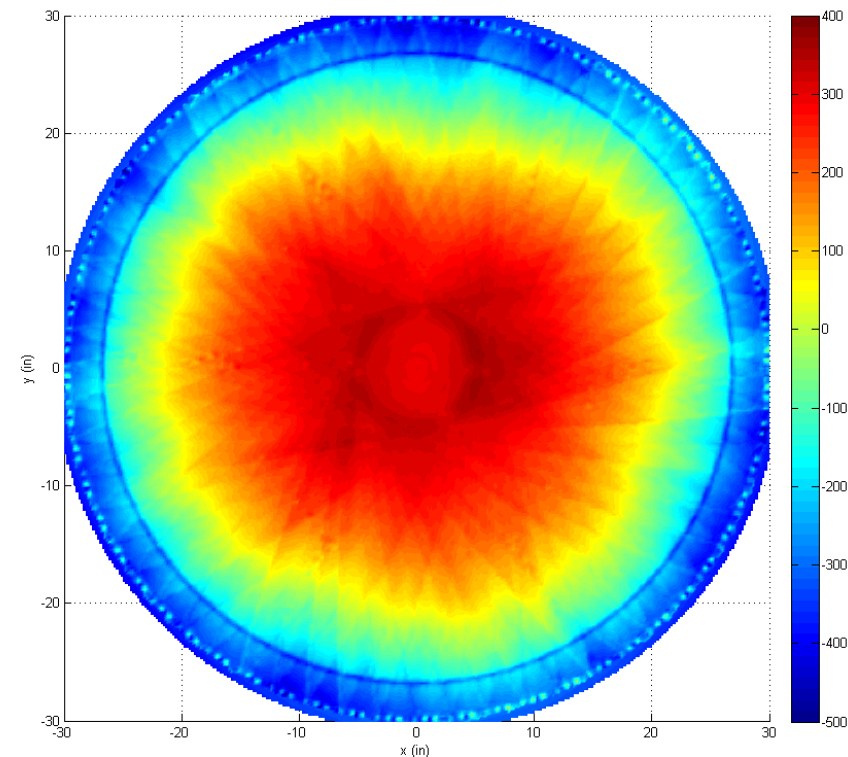


Cryo Shift Successfully Measured

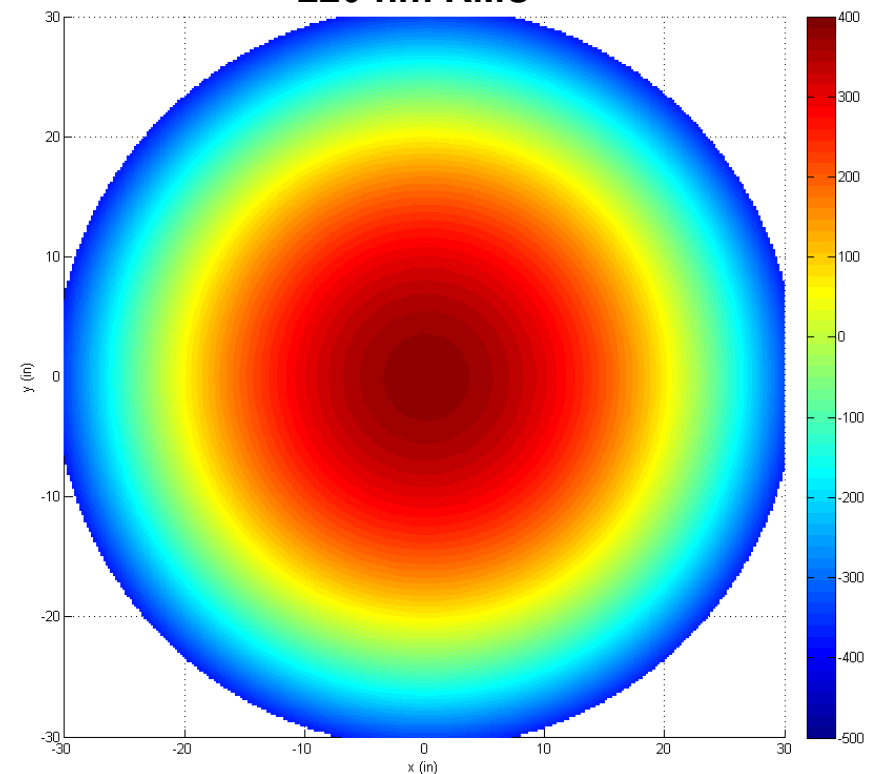


- Cryo Shift is 224 nm RMS
 - Power and Stitching Errors
 - Relatively low compared to worst-case predictions of 3000 nm RMS
- ACF2 & ACF3 to benefit from thermal facility improvements

ACF1 Cryo Shift
224 nm RMS



Power in Cryo Shift
220 nm RMS

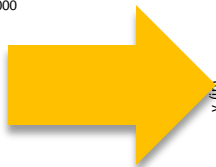
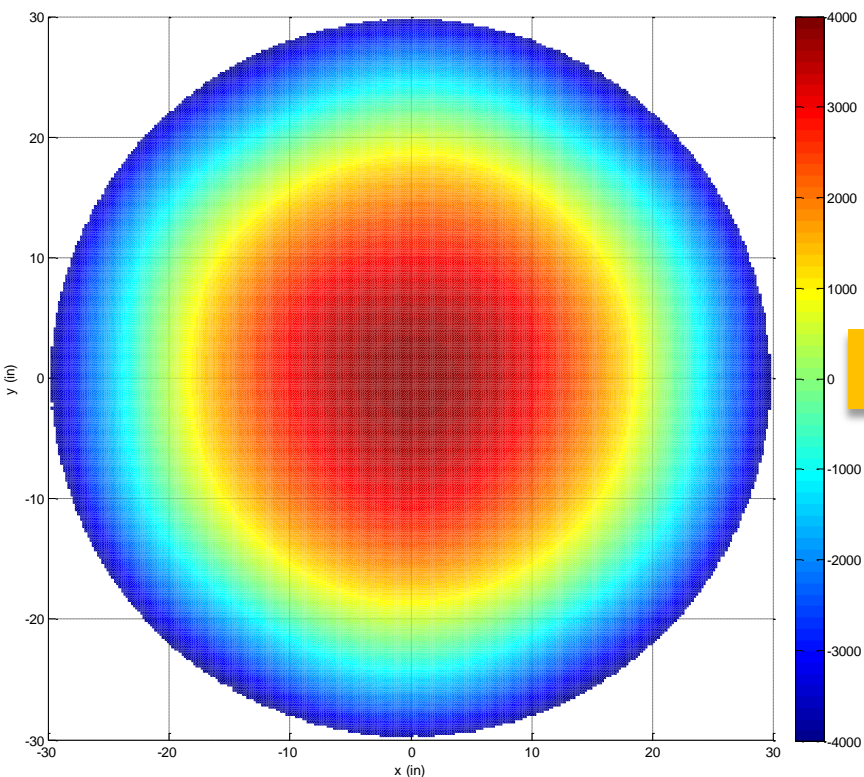




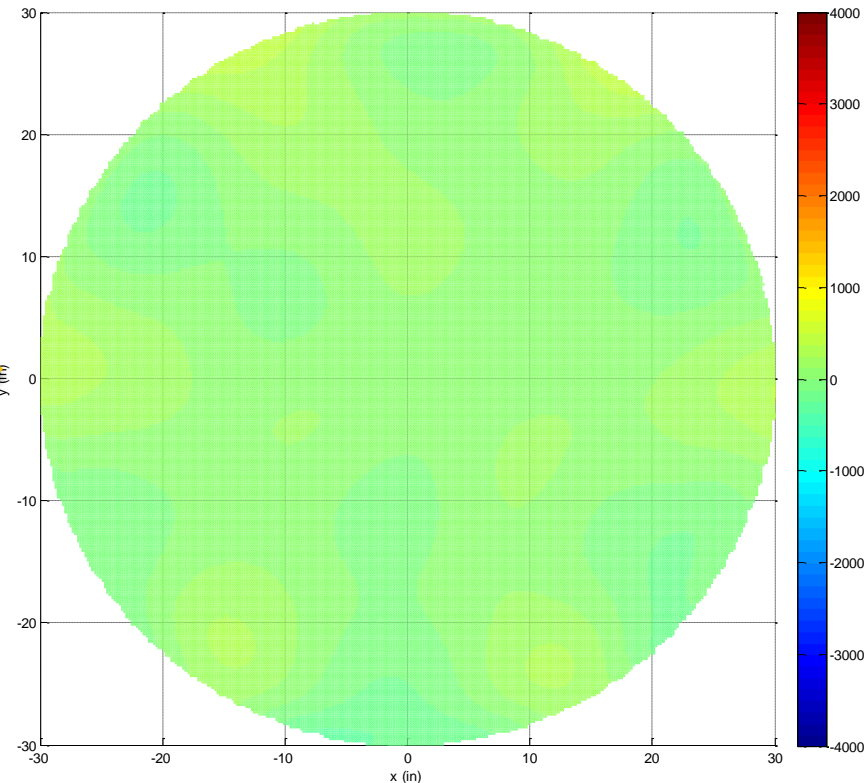
Cryo Surface Progress



Initial Surface
2184 nm RMS



Current Hitmap
108 nm RMS



Stitching Artifacts Removed for Hitmap



Summary: ACF1 Nearing Completion



- **ACF Skip Test Fully Functional**
 - Multiple Cryo-Vac Measurements at 32.8 K
 - Multiple Warm-Vac Measurements
 - Complete Backout Measured and Computed for Warm and Cryo
 - Cryo-Shift Computed & Found to be Small
- **ACF #1 Nearing Completion**
 - Final Ion Hit Beginning
 - Final Warm-Vac & Cryo-Vac Testing Planned

**Current Hitmap
108 nm RMS**

